



~~I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.~~

Dated: August 2, 2008

Signature

(Lawrence E. Russ)

EXPEDITED PROCEDURE

Group Art Unit: 2811

Docket No.: VELOX 3.0-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Pophristic et al.

Application No.: 10/780,526

: Group Art Unit: 2811

Filed: February 17, 2004

: Examiner: S. A.
: Gebremariam

For: LOW DOPED LAYER FOR NITRIDE-BASED SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 3, 2006, finally rejecting claims 1-17, 19-36, and 71-73, please amend the above-identified U.S. patent application as follows:

2811

Interest
w/ JCC
9-6-06

Shirley
9-11-06

2006,
amend